



PATENT
81839.0142

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Eiichi IINO, et al.

Serial No: 10/695,609

Filed: October 28, 2003

For: SILICON SEED CRYSTAL AND
METHOD FOR PRODUCING
SILICON SINGLE CRYSTAL

Art Unit: 1722

Examiner: M. A. Anderson

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PETITION FOR EXTENSION OF TIME

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Commissioner for Patents
P.O. Box 1450
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Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Board of Appeals for a further one-month extension of time extending to October 19, 2006, the period for response to the final Office Action dated April 19, 2006. A petition for a 2-month extension of time was filed on August 25, 2006. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

John P. Scherlacher

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